

Title (en)

THIN FILM AFFIXING DEVICE AND THIN FILM FORMATION METHOD

Title (de)

DÜNNSCHICHT-FIXIERVORRICHTUNG UND VERFAHREN ZUR BILDUNG EINER DÜNNSCHICHT

Title (fr)

DISPOSITIF DE FIXATION DE FILM MINCE ET PROCÉDÉ DE FORMATION DE FILM MINCE

Publication

EP 3520649 A1 20190807 (EN)

Application

EP 17855554 A 20170831

Priority

- JP 2016187856 A 20160927
- JP 2017031299 W 20170831

Abstract (en)

A structure where a thin film can be efficiently applied to an applied face is realized. A thin film application device used to apply a thin film on an applied face of an application object includes a frame mountable to the application object, and a thin film holding member, that has a tentative application portion to which the thin film can be tentatively applied to a side face facing the applied face in use, and that is supported by the frame so that the tentative application portion can be pressed against the applied face, and that is detachably mountable to the frame.

IPC 8 full level

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CPC (source: EP US)

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Designated contracting state (EPC)

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Designated extension state (EPC)

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